



Charge collection in MCz Si microstrip and single pad SMART detectors irradiated with 26MeV protons

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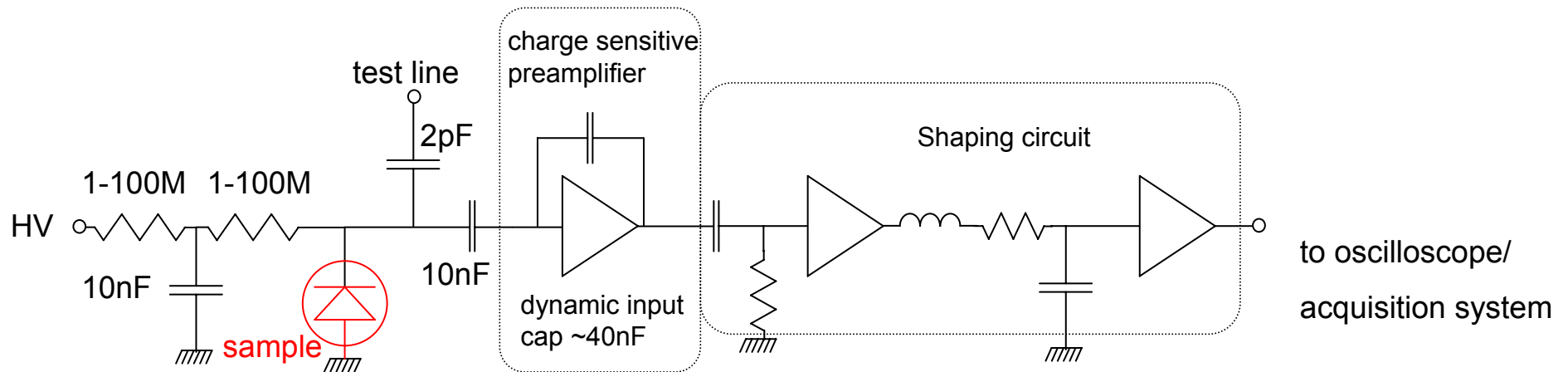
Outline

- Description of Experimental Setups
- CCE results
- Temperature/frequency dependence on CV measurements
- Comparison CCE/CV
- Conclusions

Experimental Setup (1): single pad detectors (INFN Florence)

Electronics:

Charge sensitive preamplifier + shaping circuit using Amptek components



AC coupled

Shaping time: variable from 100ns up to the order of μsec

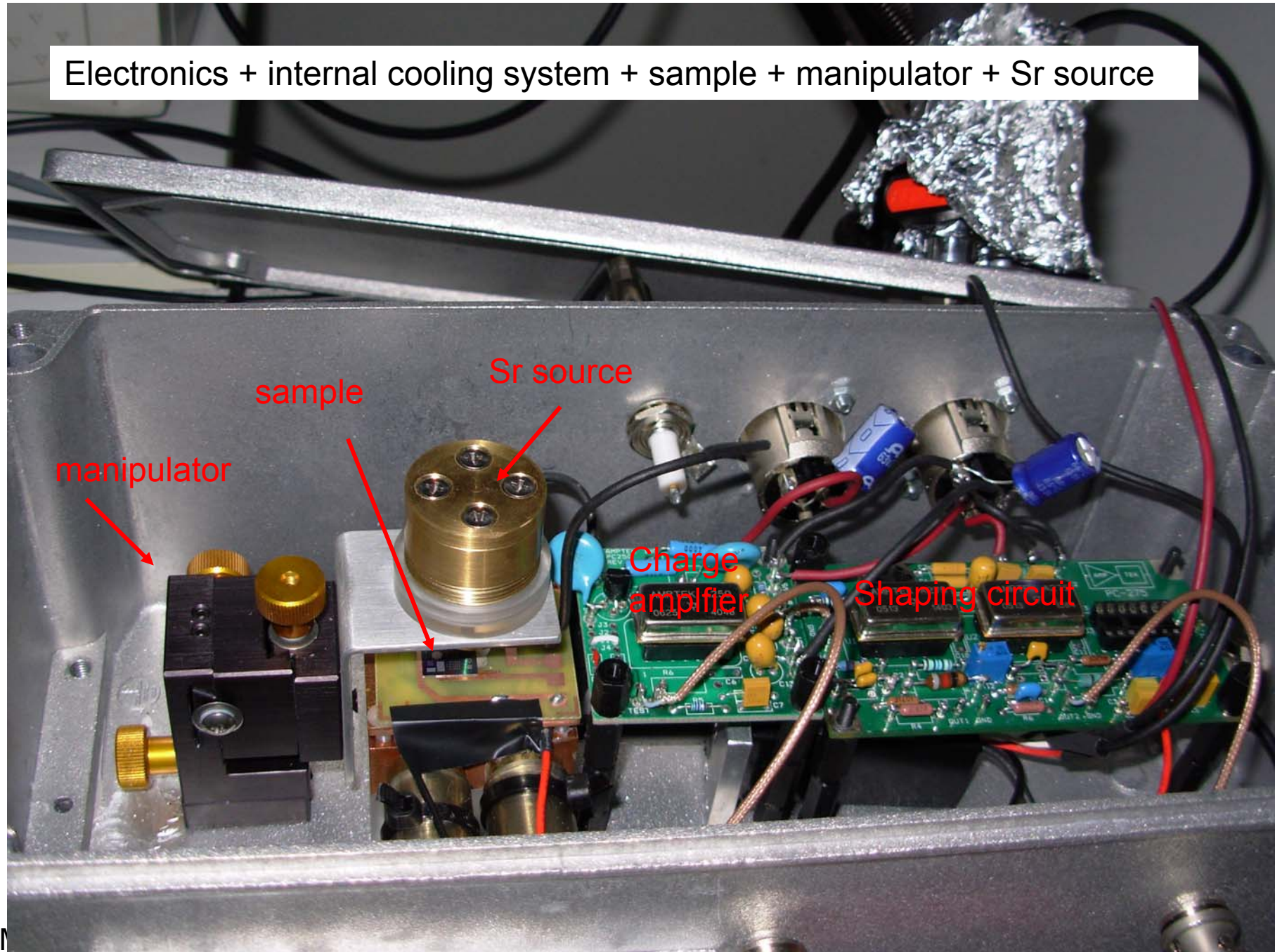
Minimum noise: $500e^-$ FWHM

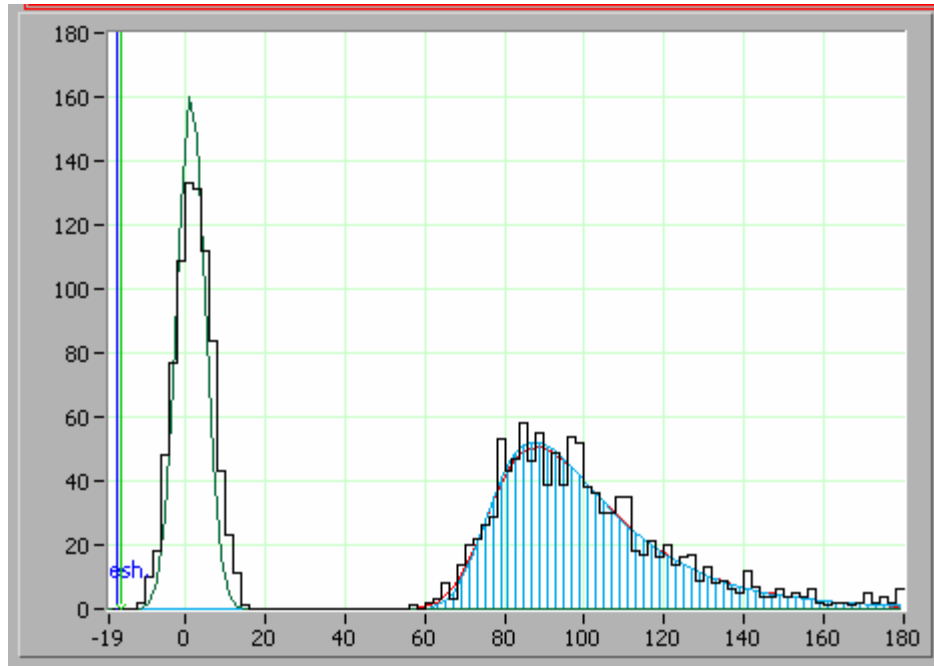
Sample temperature: down to $-30/-35^\circ\text{C}$

Source of charge signal: Sr^{90} 0.1mCi

Trigger line: scintillator+light guide+PMT (from NIKHEF)

Electronics + internal cooling system + sample + manipulator + Sr source





p-type Si diode

Non-irradiated

Measurement on irradiated
diodes in progress

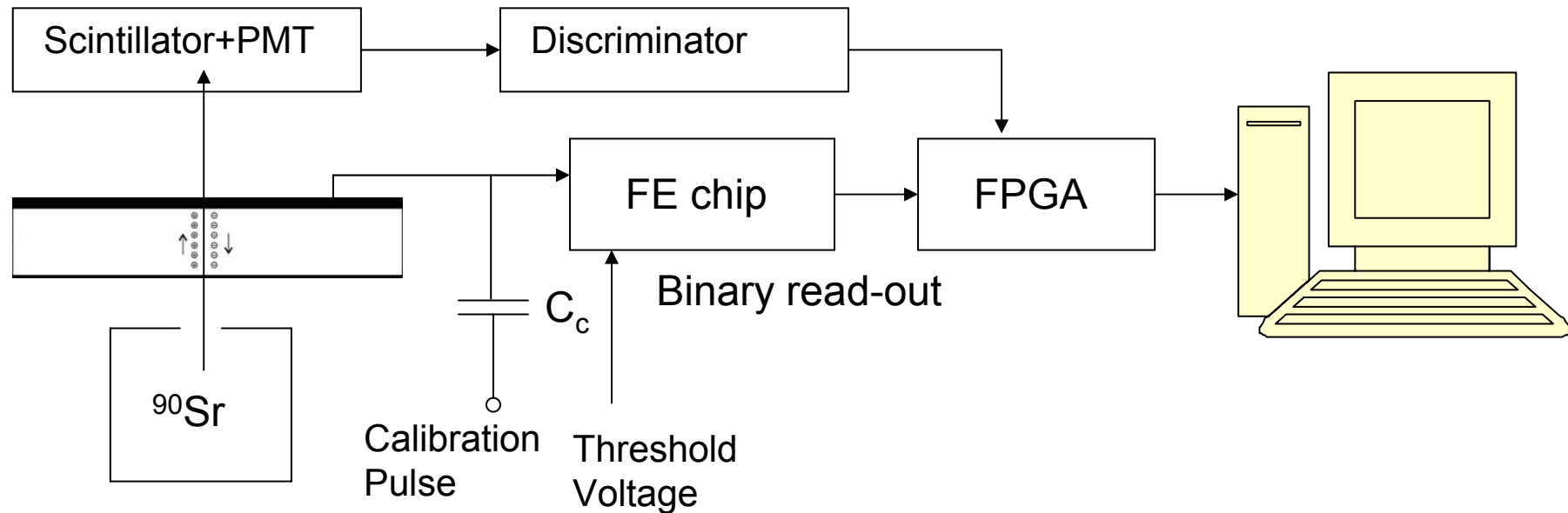
Applied Voltage: 125V (fully depleted)

Most probable deconvoluted Landau peak at $85 \pm 2 \text{mV}$

Calibration gives $1 \text{mV} = 260 \pm 5 e^-$ so $85 \pm 2 \text{mV} \sim 22000 e^-$

Noise $750 e^-$

Experimental Setup (2): microstrip detectors (SCIPP)

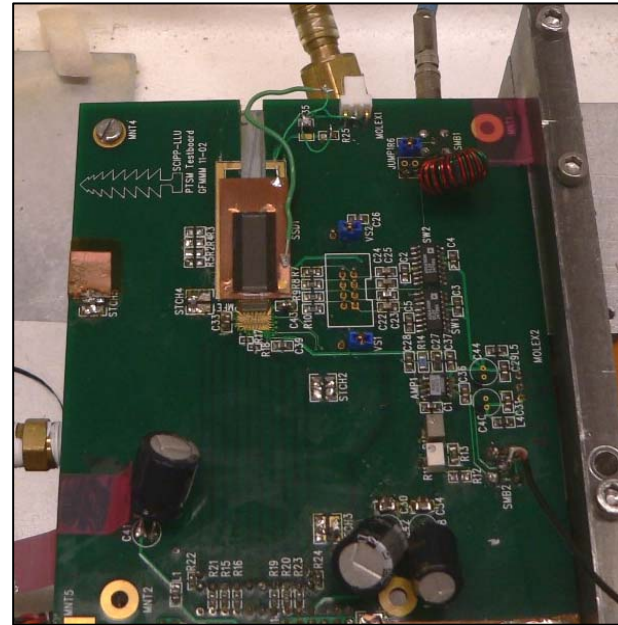
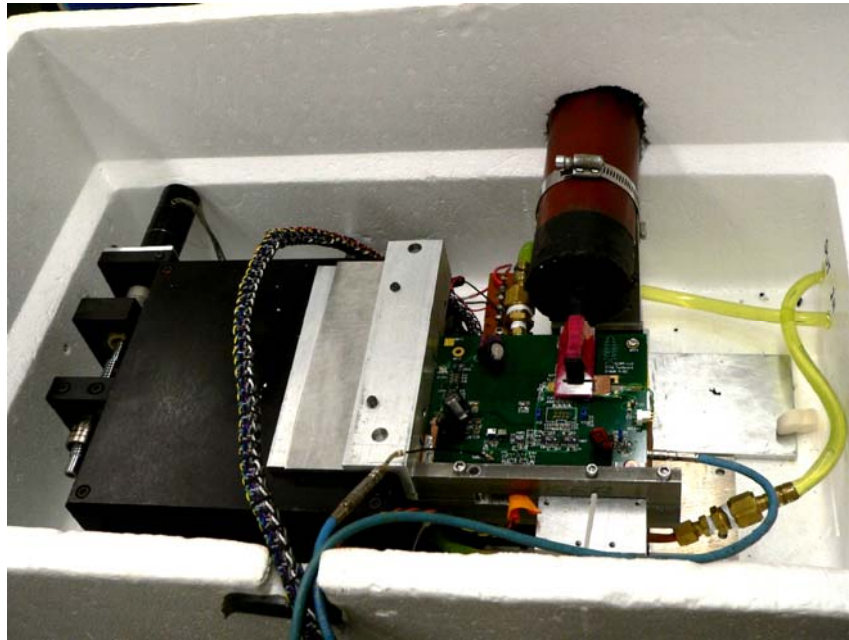


- Hits from scintillator and silicon detector are read out

For fixed threshold and bias voltage:

efficiency = coincidences / scintillator hits

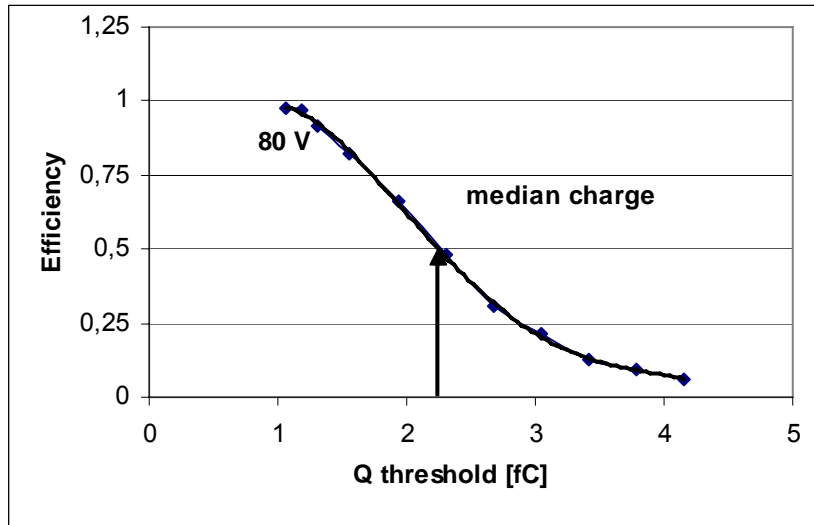
Experimental Setup (2): microstrip detectors



- Shaping time: 100 ns
- Cooling: down to $-10 \div -30$ °C (liquid nitrogen)
- Scintillator rate $20 \div 30$ Hz

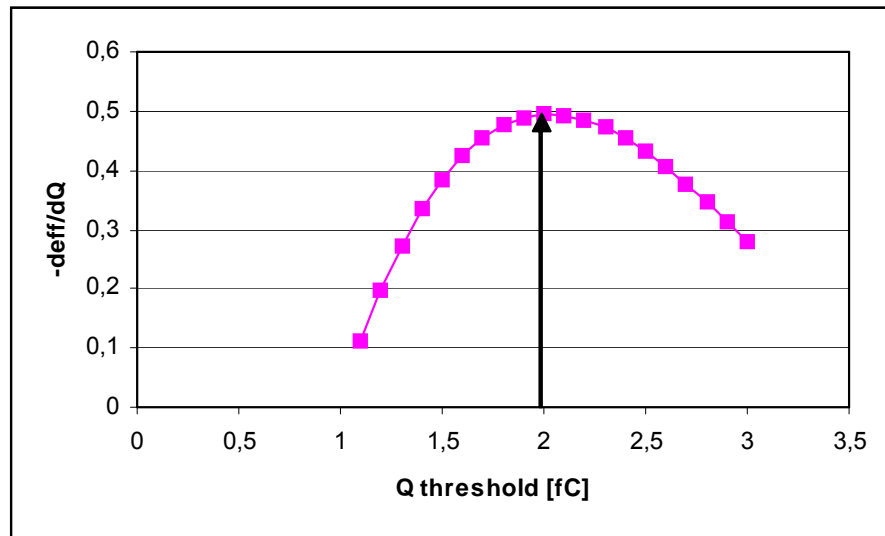
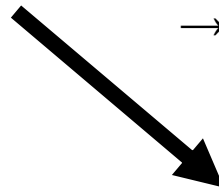


Reconstruction of pulse spectrum



Fit and differentiate

→ Pulse Spectrum



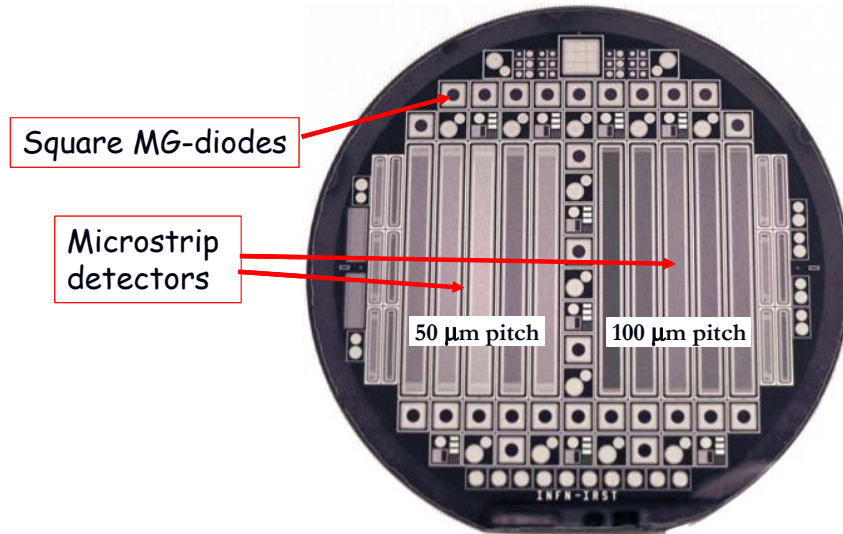
50% Point = Median charge

n-type MCz Si microstrip
26 MeV p irradiated, $\Phi = 3.3 \times 10^{14} \text{cm}^{-2}$
Vrev=80 V
T -10°C

Maximum = Most probable charge

Samples

Wafer layout - SMART



Processed at ITC-IRST

Magnetic Cz Si from Okmetic, Finland

**Mask: 10 mini-strip + single pad diodes
+ test structures**

**Strips: 0.6x4.7cm², 50/100μm pitch, AC
coupled**

Tested Devices: p-type diodes, n-,p- type microstrips

Irradiation: Karlsruhe 26MeV protons

Detector thickness: 300μm

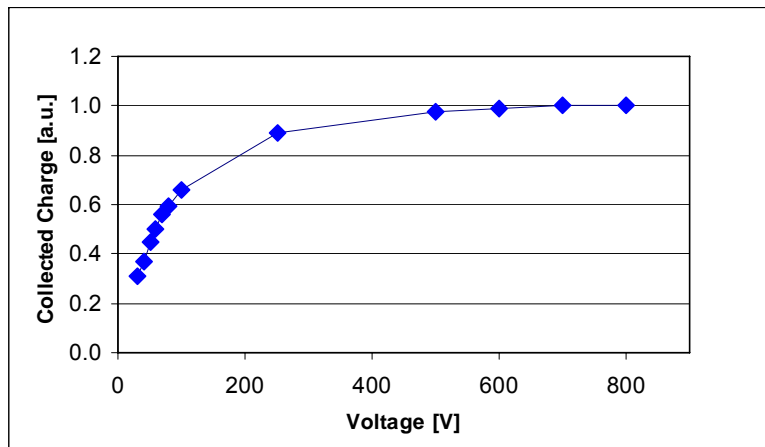
Fluences studied in this work:

4×10^{13} - $7 \times 10^{14} \text{cm}^{-2}$ 1MeV neutron equivalent

CCE vs reverse voltage: microstrips

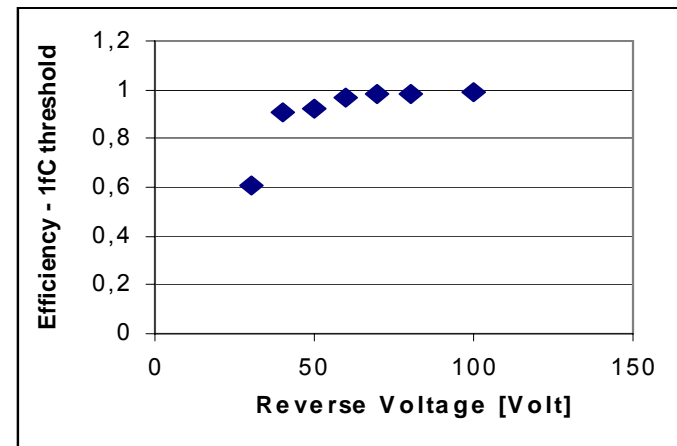
MCz n-type, $\Phi=3.3\times 10^{14}$ n/cm²

Median charge vs. applied voltage normalized to saturation value



Calibration procedure is under test to estimate the absolute value of the collected charge

Efficiency at 1 fC threshold

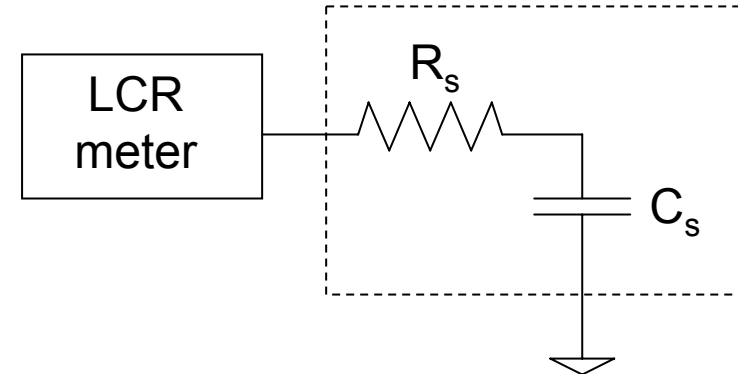
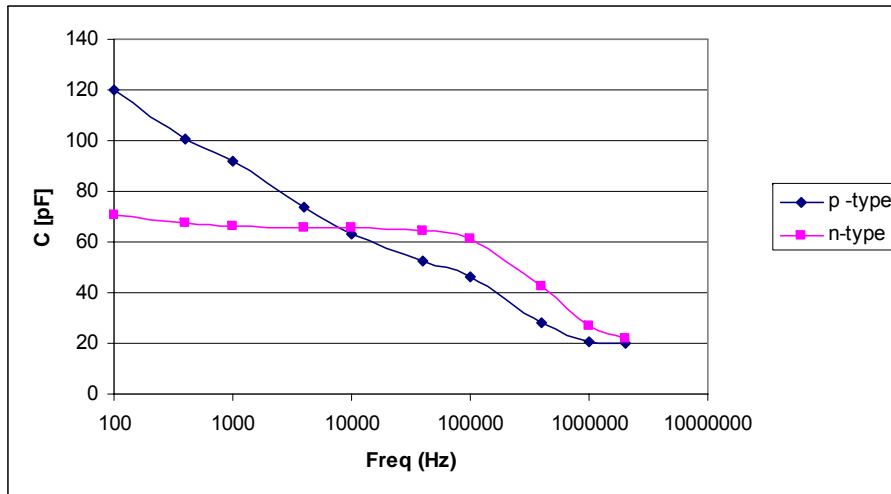


Saturation to 100% efficiency is reached at $V_{rev}=60$ V

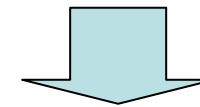
CV measurements: frequency dependence

Unirradiated microstrip detectors

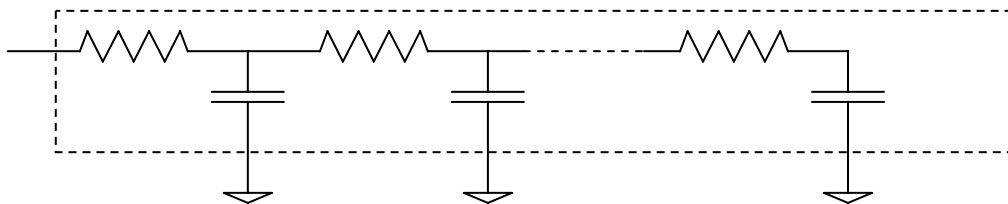
C vs F at full depletion



- N-type: C is flat up to $f \sim 100$ kHz
- P-type: C is f dependent in the whole investigated range



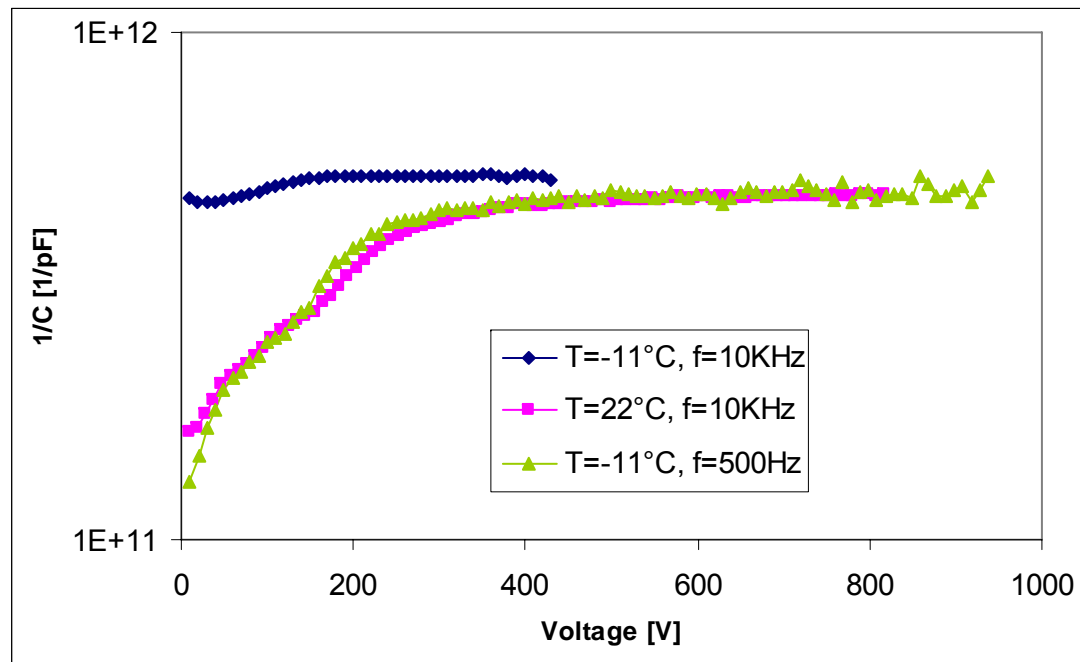
Strip equivalent circuit:



Simulations under way to extract the correct C value in p-type unirradiated microstrips

CV measurements: frequency-temperature correlation

Single Pad detector, MCz n-type, $\Phi=7 \times 10^{14}$ n/cm²



Leakage current due to midgap levels

$$I(T) \propto T^2 \exp\left(-\frac{E_g}{2KT}\right)$$

$$f(T) = \frac{e_n(T)}{e_n(RT)} f(RT) \approx \frac{I(T)}{I(RT)} f(RT)$$

Frequency dependence is due to charge/discharge of deep traps

$$\tau \approx \frac{1}{e_n}$$

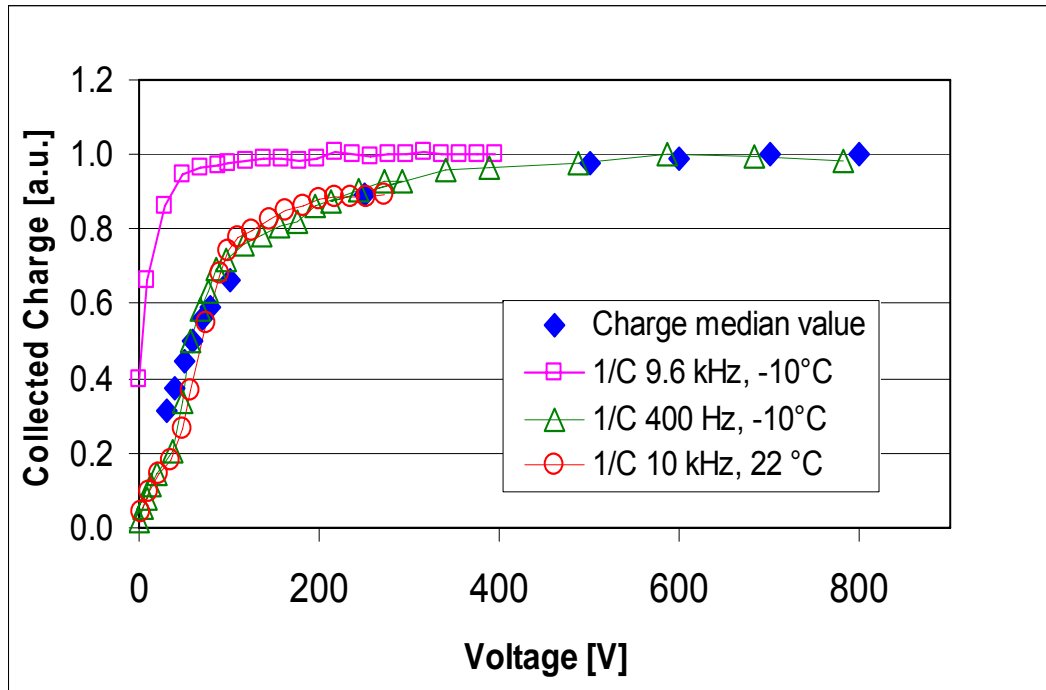
Emission coefficient

$$e_n \propto T^2 \exp\left(-\frac{E_t}{KT}\right)$$

Cut frequency $f_c \sim e_n$

CCE – CV Comparison

MCz n-type microstrip, $\Phi=3.3 \times 10^{14}$ n/cm²



- Low T 10kHz C-V does not fit the charge collection profile
- best fit is obtained at -11°C with a frequency of 400Hz, calculated by the above mentioned formula

Conclusions

- A new low noise experimental setup for CCE measurements on single pad detectors has been constructed, measurements on irradiated structures are under way
- Setup for microstrip detectors has been upgraded for low temperature operation (cooling system down to $-10 \div -30^{\circ}\text{C}$)
- CCE and CV measurements have been performed on MCz microstrip and single pad silicon detectors processed by ITC – IRST, Trento before and after 26 MeV proton irradiation up to a fluence of $7 \times 10^{14} \text{ cm}^{-2}$ 1 MeV neutron equivalent
 - We have developed a procedure to scale the test frequency in CV measurements with temperature in n-type irradiated microstrip detectors.
 - Simulations under way for p-type microstrips to extract the value of the capacitance in unirradiated and irradiated microstrips.